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(71) Applicant (for all designated States except US): CALIFORNIA INSTITUTE OF TECHNOLOGY [US/US];
1200 East California Blvd., Pasadena, CA 92115 (US).

(72) Inventors; and

(75) Inventors/Applicants (for US only): UNGER, Marc, A. [US/US]; 48 S. Oak Avenue, #5, Pasadena, CA 91107 (US). CHOU, Hou-Pu [—/US]; 1028 E. Del Mar Blvd.

#207, Pasadena, CA 91106 (US). THORSEN, Todd, A. [US/US]; 810 N. Michigan Avenue, Pasadena, CA 91104 (US). SCHERER, Axel [US/US]; 1900 Catalina Street, Laguna Beach, CA 92651 (US). QUAKE, Stephen, R. [US/US]; 744 Plymouth Road, San Marino, CA 91108 (US).

(74) Agents: TOBIN, Kent et al.; Townsend and Townsend and Crew LLP, Two Embarcadero Center, 8th Floor, San Francisco, CA 94111 (US).

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(54) Title: MICROFABRICATED ELASTOMERIC VALVE AND PUMP SYSTEMS

(57) Abstract: A method of fabricating an elastomeric structure, comprising : forming a first elastomeric layer on top of a first micromachined mold, the first micromachined mold having a first raised protrusion which forms a first recess extending along a bottom surface of the first elastomeric layer; forming a second elastomeric layer on top of a second micromachined mold, the second micromachined mold having a second raised protrusion which forms a second recess extending along a bottom surface of the second elastomeric layer; bonding the bottom surface of the second elastomeric layer onto a top surface of the first elastomeric layer such that a control channel forms in the second recess between the first and second elastomeric layers; and positioning the first elastomeric layer on top of a planar substrate such that a flow channel forms in the first recess between the first elastomeric layer and the planar substrate.